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Flow Control Device:

Disk

Disk Loading Method:

Spring

Renewable Seat Ring Type:

Pressed-in

End Application:

New construction lcs1

Valve Operation Method:

Automatic

Product Name:

Wafer style swing check valve; inavy: 4" check wafer

Special Features:

Pressure class: 150; 4 inch wafer swing check valve; flow rate: 1000 gpm @ 60 degrees f

Material:

Stainless steel flow control device

Material Specification:

Viton mfr ref single material response seat

Style Designator:

Straight thru

Shelf Life:

N/a

Unit Of Measure:

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Demilitarization:

No

Fiig:

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